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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 00044)

Applicant(s): Homer CHOU et al.

Serial No.: 10/043,534

Filing Date: January 10, 2002

For: AMMONIUM OXALATE-
CONTAINING POLISHING
SYSTEM AND METHOD

Examiner: Not yet known

Group Art Unit: 2812

CERTIFICATE OF MAILING

I, MARIEJOSE MONSALVE, HEREBY CERTIFY THAT THIS CORRESPONDENCE AND ENCLOSURE(S), IF ANY, ARE HEREBY BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE IN AN ENVELOPE WITH SUFFICIENT POSTAGE FOR FIRST CLASS MAIL DELIVERY TO THE USPTO AT THE BOX/ADDRESS INDICATED BELOW.

(Depositor's signature)

09 AUG 2002

(Date)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, D. C. 20231

Further to Information Disclosure Statement previously filed in the captioned matter. Applicant(s) list(s) documents that may be material to the examination of this application on the attached form PTO/SB/08A. Copies of each of the listed documents are enclosed with the mailed copy of this paper.

Pursuant to 37 C.F.R. §§1.97(c) and 1.97(e)(1), the undersigned hereby states that each item contained in this Information Disclosure Statement was cited in a communication received from the International Searching Authority in connection with a patent application corresponding to this matter not more than three months prior to the filing of this statement. A copy of the pertinent pages of the communication from the ISA/EP are enclosed.

The right to later set forth how the claimed invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and documents referenced herein, and those that may be cited by the Examiner in rejecting a claim in the instant patent application is reserved.

The referenced documents are cited to ensure that the Examiner has the benefit of all the information of which the Applicants are aware which may be helpful to the U.S. Patent and Trademark Office in its examination of this application. The Examiner is requested to review the documents and determine the extent of materiality of the disclosures with respect to the present invention.

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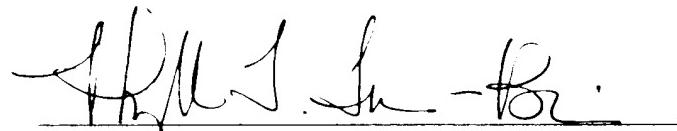
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(Date)	

As this paper is being timely submitted, no fees are believed to be due. However, this authority is hereby authorized to charge any deficiency or credit any overpayment in connection with this filing to Deposit Account No. 501599.

Respectfully submitted,

Date: 09 AUG 2002



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Comparable to Form PTO SB-08A

INFORMATION DISCLOSURE STATEMENT BY APPLICANT



Complete if Known

Application Number:	10 043,534
Filing Date:	January 10, 2002
First Named Inventor:	Chou et al.
Art Unit	2812
Examiner Name:	Not yet known
Atty. Docket No.	00044

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear	T
		Country Code-Number-Kind Code (if known)				
	1.	WO 01 04226 A	18JAN2001	Cabot Microelectronics Corp.	See enclosed copy of ISR	N/A
	2.	WO 98 49723 A	05NOV1998	Minnesota Mining	See enclosed copy of ISR	N/A

OTHER DOCUMENTS (NON PATENT LITERATURE DOCUMENTS)

Examiner Initials	Cite No.	Author's NAME, title of the article, book, magazine, journal, serial, symposium, catalog, etc., date, page(s), volume-issue number(s), publisher, city and/or country of publication	T

Examiner's Signature

Date Considered